

USE RCE DATE 11-30-07

DOCKET NO.: 240882US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF

TOMOHISA KONNO ET AL : EXAMINER: RACHUBA, MAURINA T.

SERIAL NO.: 10/626,521 :

FILED: JULY 25, 2003 : GROUP ART UNIT: 3723

FOR: AQUEOUS DISPERSION FOR  
CHEMICAL MECHANICAL POLISHING  
AND PRODUCTION PROCESS OF  
SEMICONDUCTOR DEVICE :

"RESPONSE UNDER 37 CFR 1.116-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 3223"

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 6, 2007, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.